

<b>Notice of References Cited</b>	Application/Control No. 10/721,178	Applicant(s)/Patent Under Reexamination LU ET AL.	
	Examiner Daniel Kim	Art Unit 2185	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0100994	05-2004	Miller, Glen W.	370/503
*	B	US-7,047,385	05-2006	Bhattacharya et al.	711/169
*	C	US-6,505,269	01-2003	Potter, Kenneth H.	711/202
*	D	US-2002/0156995	10-2002	Martin et al.	712/201
*	E	US-2003/0037226	02-2003	Tsuruta et al.	712/228
*	F	US-6,052,802	04-2000	Zahir et al.	714/47
*	G	US-5,867,683	02-1999	Witt et al.	712/218
*	H	US-6,732,247	05-2004	Berg et al.	711/169
*	I	US-2003/0097541	05-2003	Abrosimov et al.	712/1
*	J	US-7,071,748	07-2006	Wich, Mathew T.	327/176
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.